-1690

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Patent Application of

Ichiro FUJIWARA

Serial No. 09/431,076

Filed: November 1, 1999

Group Art Unit: 2811

Examiner: Hung VU

NONVOLATILE SEMICONDUCTOR MEMORY DEVICE AND PROCESS OF For:

PRODUCTION AND WRITE METHOD THEREOF

## AMENDMENT

MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed March 24, 2003 (Paper No. 15), please amend the application as follows:

1